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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Yasuyuki MATSUI et al.

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| CONF. NO.: 4014

FILED: October 3, 2005

FOR: METHOD OF MANUFACTURING SINGLE-CRYSTAL BLOCKS FOR SLICING  
OFF SEMICONDUCTOR WAFERS THEREFROM

COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

April 3, 2007

STATUS REQUEST

Dear Sir:

Please inform us of the status of the processing of this  
application in the USPTO.

Respectfully submitted  
Yasuyuki MATSUI et al. - Applicant

WFF:ks/4917

Enclosure:  
postcard

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CERTIFICATE OF MAILING:

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Karin Smith - April 3, 2007

Name: Karin Smith - Date: April 3, 2007